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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF:  
Marc DELAUNAY, et al.

: GROUP: 2881

SERIAL NUMBER: 10/019,278

: ATTENTION:  
Application Division  
Customer Corrections

FILED: JANUARY 02, 2002

FOR: METHOD AND DEVICE FOR ELECTRONIC CYCLOTRONIC RESONANCE  
PLASMA DEPOSITE OF CARBON NANOFIBRE LAYERS IN FABRIC FORM AND  
RESULTING FABRIC LAYERS

REQUEST FOR CORRECTED OFFICIAL FILING RECEIPT

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

The Patent Office is requested to provide a corrected Official Filing Receipt for the attached. If you have any questions, please do not hesitate to contact us.

No fees are required. However, in the event that a fee is required, please charge the appropriate amount to our Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,  
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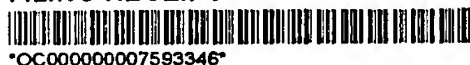
## UNITED STATES PATENT AND TRADEMARK OFFICE

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APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO.	DRAWINGS	TOT CLAIMS	IND CLAIMS
10/019,278	01/02/2002	2881	1070	217218US2PCT	4	30	3

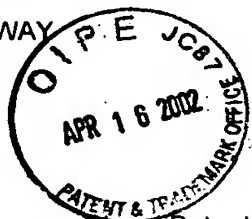
CONFIRMATION NO. 7791

## FILING RECEIPT



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Date Mailed: 03/11/2002

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

## Applicant(s)

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## Domestic Priority data as claimed by applicant

THIS APPLICATION IS A 371 OF PCT/FR00/01827 06/29/2000

## Foreign Applications

FRANCE 99/08473 07/01/1999

Projected Publication Date: Not Applicable, filed prior to November 29,2000

Non-Publication Request: No

Early Publication Request: No

## Title

Method and device for electronic cyclotron resonance plasma deposite of carbon nanofibre  
layers in fabric form and resulting fabric layers

## Preliminary Class

250

PLEASE NOTE THAT THE SECOND APPLICANT'S CITY IS INCORRECT. IT SHOULD  
READ AS FOLLOWS:

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